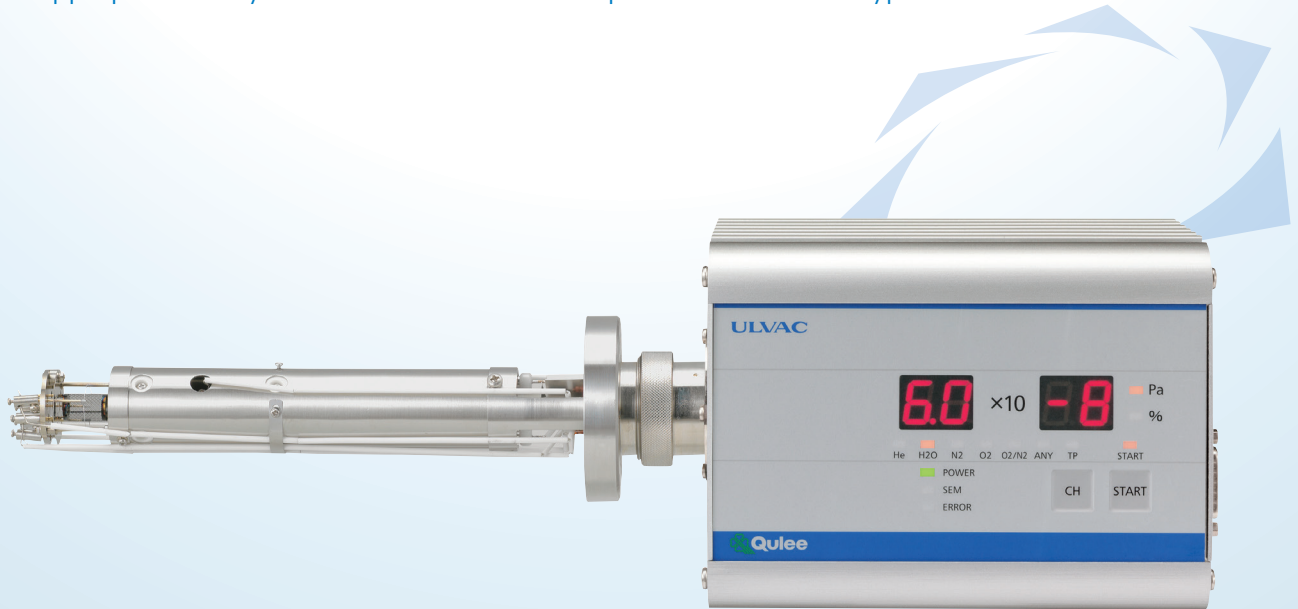


Basic Process Gas Monitor [Qulee BGM2 Series]

"Qulee" (pronounced as "KLEE"), is ULVAC's latest model for residual gas analysis. Feedback from facility engineers in various production lines are incorporated in the new product design offering utmost simplicity.(Ethernet compatible)

Most appropriate for system control of vacuum evaporator and various types of vacuum furnaces.



Features

- ▶ **Excellent in Cost Performance**
Suitable for RGA application
- ▶ **Communication interface**
Ethernet compatible
- ▶ **Integrated Display**
No need for PC
- ▶ **Simple Operation**
"One Click" function
- ▶ **Bake Out**
Max 120°C (248°F) high temperature bake (250°C (482°F) when sensors are removed)
- ▶ **Degas Function**
Electron bombard degas
- ▶ **Protection and Maintenance Features**
Ion source and secondary electron multiplier protection maintenance help function
- ▶ **Various Leak Tests are Available**
Helium leak test, air leak test, leak up
- ▶ **Total Pressure Measurement**
Capable of total pressure measurement

- ▶ **Qulee QCS is Included**
This software is included and compatible with (Windows 7/8/10)
- ▶ **Applicable Standard**
Conforms with CE

Applications

- ▶ Residual gas analysis for organic electro luminescence
- ▶ Residual gas monitoring for PV, FPD, and semiconductor manufacturing system
- ▶ Residual gas analysis in PVD system and vacuum deposition
- ▶ Residual gas analysis for high vacuum pumping equipment, etc.
- ▶ Residual gas analysis for freeze drying system
- ▶ Various types of gas analysis for research and development